

**Notice of References Cited**

Application/Control No.

10/533,245

Applicant(s)/Patent Under  
Reexamination  
DAM NIELSEN ET AL.

Examiner

Dai A. Phuong

Art Unit

2617

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0032414	02-2003	Melaku et al.	455/415
*	B	US-2002/0126146	09-2002	Burns et al.	345/752
*	C	US-2002/0094806	07-2002	Kamimura, Sawa	455/415
*	D	US-5,907,604	05-1999	Hsu, P. Robert	379/142.06
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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